



PATENT
Attorney's Docket No. 015675.P326

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
SEP 26 2003
TC 1700

In re Application of:

ANDRE LEYCURAS

Serial No.: 09/601,109

Filed: October 16, 2000

For: **CHEMICAL VAPOR DEPOSITION
REACTOR AND PROCESS**

Examiner: Lund, Jeffrie Robert

Art Group: 1763

Mail Stop RCE
Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

PRELIMINARY AMENDMENT

In connection with the Request for Continued Examination under 37 C.F.R. §1.114,
Applicant respectfully requests entry of the following amendments.